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JC07 Rec'd PCT/PTO 31 JAN 2002

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Toshikazu SEGAWA et al

Art Unit:

S. N.

Examiner:

International S.N.: PCT/JP01/01446

Filed: October 25, 2001

International Filing Date: 27 February 2001

For: METHOD OF PRODUCING PHASE MASK FOR
PROCESSING OPTICAL FIBER AND OPTICAL
FIBER WITH BRAGG DIFFRACTION GRATING
FABRICATED BY USING THE OPTICAL
FIBER-PROCESSING PHASE MASK

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INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Applicants wish to draw attention to the documents listed on the accompanying Form PTO-1449, copies of which documents are enclosed.

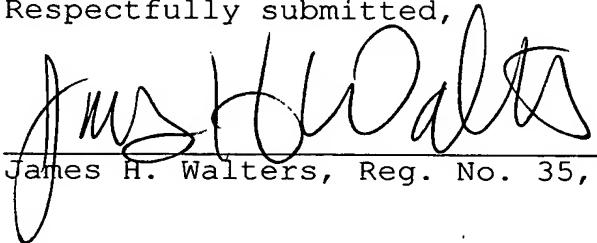
The documents were cited in the counterpart PCT patent application, and a copy of the International Search Report (Form PCT/ISA/210 (second sheet)) is enclosed.

Pursuant to MPEP 609 A(3), it is believed that the indication of relevance of the non-English documents given in the International Search Report satisfies the requirement in 37 CFR 1.98(a)(3) for a concise explanation of relevance with respect to these non-English documents.

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Pursuant to MPEP 609, it is requested that the Examiner should initial Form PTO-1449 to confirm that each document has been considered, and return a copy of the form to the undersigned.

Respectfully submitted,

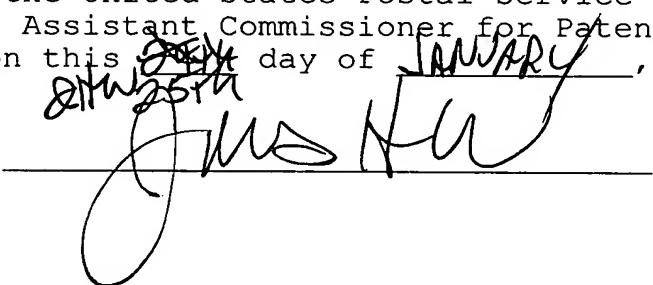


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I hereby certify that this correspondence is being deposited as first class mail with the United States Postal Service in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231, on this 25th day of JANUARY, 2002.



***EXAMINER:** Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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